IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

oplication Serial No	80
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ventor Moore et	al.
ssignee Micron Technology, I	nc.
roup Art Unit	wn
raminer	wn
torney's Docket No MI22-17	
tle: Capacitors, Methods of Forming Capacitors, and Methods of Forming Capaci	itor
Dielectric Lavers	

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449, copies of which are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of the referenced art is respectfully requested.

This Information Disclosure Statement is being filed within three months of the filing date of the application or before the mailing of a first Office Action, whichever occurs last. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this information disclosure statement, please charge the fee specified under 37 C.F.R. § 1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

Respectfully submitted,

Dated: <u>4-23-02</u>

Mark S. Matkin, P.S. Reg. No. 32,268

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